

**LIST OF PRIOR ART CITED BY
APPLICANT
(PTO-1449)**

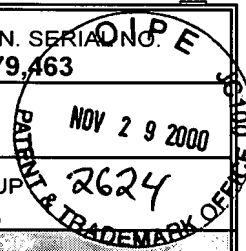
ATTY. DOCKET NO.
CIT/K-081

APPLN. SERIAL NO.
09/379,463

APPLICANT(S)
Jae Min KIM

FILING DATE
August 24, 1999

GROUP
2724



U.S. PATENT DOCUMENTS

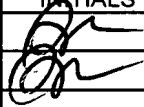
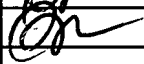
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	JP9-326024	12/16/97	JAPAN			Abstract	
	JP10-70719	3/10/98	JAPAN			Abstract	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER 	DATE CONSIDERED 4/6/03
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.